



#8/Election/A  
DKing  
7/29/03

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2828

Application No.: 10/026,637

Examiner: James W. Davie

Filed: December 27, 2001

Docket No.: 111587

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING  
METHOD THEREOF

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 23, 2003 Office Action, please consider the following

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**

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JUL 23 2003  
TECHNOLOGY CENTER 2800

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